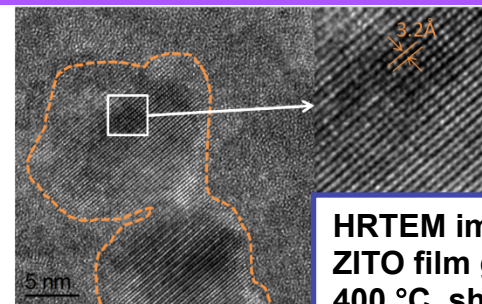




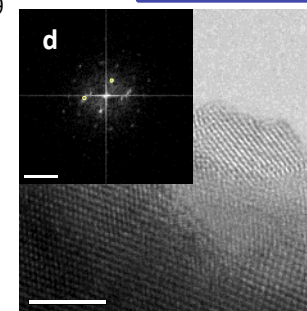
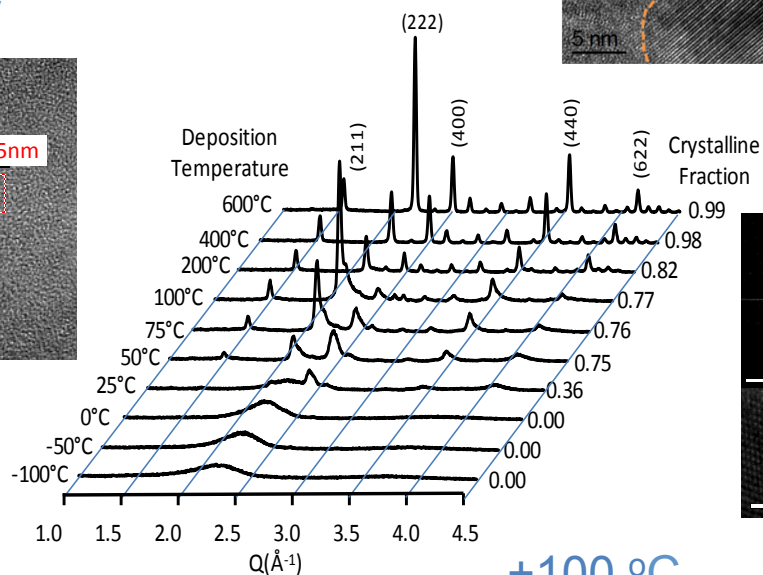
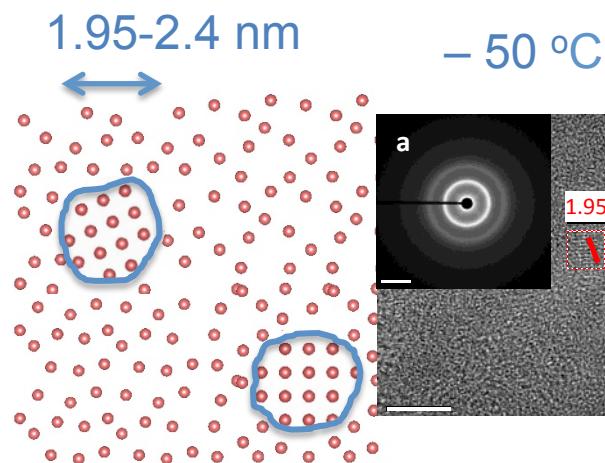
# Length scales across the *c-a* transition



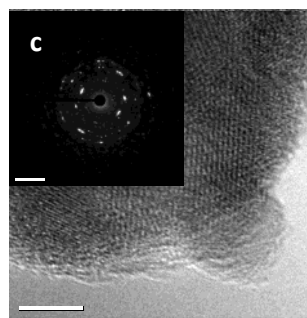
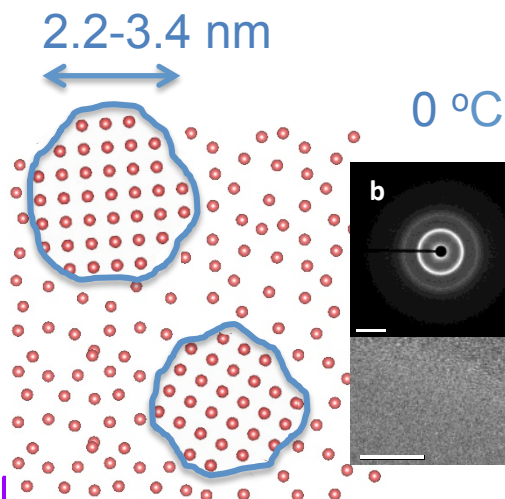
a-IO films prepared by PLD at different deposition temperatures; X-ray, HRTEM



HRTEM image of a-ZITO film grown at 400 °C, showing a crystalline ZITO phase embedded in a disordered matrix



+600 °C



+100 °C

